

Notic of References Cited

Application/Control No.

10/071,809

Applicant(s)/Patent Under

Reexamination

WANG, TINGHAO F.

Examiner

DuyVu n Deo

Art Unit

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Langley et al., "One-Chamber Polycide Sandwich Etching," Semiconductor International, Oct. 1989, page 95-97.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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